



09-02-05

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Express Mail No. EV 346 793 826 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Michel POULENARD

Confirmation No. 2568

Application No: 10/663,545

Group Art Unit: 1614

Filing Date: September 15, 2003

Examiner:

For: INSTALLATION FOR TREATING
SEMICONDUCTOR WAFERS

Atty. Docket No.: 4717-11100

REQUEST FOR CORRECTION OF FILING RECEIPT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

A filing receipt for the above-identified application has been received and the following correction is respectfully requested:

The incorrect foreign priority data was inadvertently entered when the application was filed. Please correct and insert the **Foreign Application** data to read:

--FRANCE 0302694 - 03/05/2003--

A copy of the incorrect filing receipt along with a copy of the inventor's declaration are enclosed herewith in support of this change. No fee is believed to be due for this submission. Please charge any required fees to WINSTON & STRAWN LLP Deposit Account No. **50-1814**.

Respectfully submitted,

Date: _____

8/31/05

Allan A. Fanucci (Reg. No. 30,256)

WINSTON & STRAWN
CUSTOMER NO. 28765
(212) 294-3311

Enclosures

NY:974963.1



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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/663,545	09/15/2003	1614	894	4717-11100	6	28	3

CONFIRMATION NO. 2568

28765
 WINSTON & STRAWN
 PATENT DEPARTMENT
 1400 L STREET, N.W.
 WASHINGTON, DC 20005-3502

FILING RECEIPT



OC000000011456607

Date Mailed: 12/10/2003

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)

Michel Poulenard, Voreppe, FRANCE;

Domestic Priority data as claimed by applicant

P/s. Correct

Foreign Applications

FRANCE 0308392 - 07/09/2003

-FRANCE 0302694 - 03/05/2003-

If Required, Foreign Filing License Granted: 12/09/2003

Projected Publication Date: 01/13/2005

Non-Publication Request: No

Early Publication Request: No

Title

Installation for treating semiconductor wafers

Preliminary Class

RECEIVED

DEC 1 2 2003

WINSTON & STRAWN
DOCKETING DEPT. (D.C.)

**LICENSE FOR FOREIGN FILING UNDER
Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

GRANTED

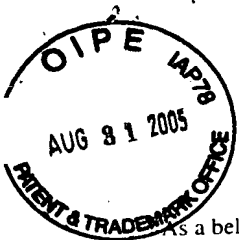
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DECLARATION FOR NON-PROVISIONAL PATENT APPLICATION

As a below named inventor, I hereby declare that:

My residence, post office address and citizenship are as stated below at 201 et seq. beneath my name.

I believe I am the original, first and sole inventor if only one name is listed at 201 below, or an original, first and joint inventor if plural names are listed at 201 et seq. below, of the subject matter which is claimed and for which a patent is sought on the invention entitled

INSTALLATION FOR TREATING SEMICONDUCTOR WAFERS

- ☒ is attached hereto.
☒ which is identified by docket No. 4717-11100
☐ which was filed on _____ as Application No. _____.

I hereby state that I have reviewed and understand the contents of the above identified application, including the claims, as amended by any amendment referred to above.

I acknowledge the duty to disclose information known to me to be material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56.

I hereby claim foreign priority benefits under Title 35, United States Code, § 119(a)-(d) of any foreign application(s) for patent or inventor's certificate listed below and have also identified below any foreign application for patent or inventor's certificate having a filing date before that of the application on which priority is claimed:

EARLIEST FOREIGN APPLICATION(S), IF ANY, FILED PRIOR TO THE FILING DATE OF THE APPLICATION			
APPLICATION NUMBER	COUNTRY	DATE OF FILING (day, month, year)	PRIORITY CLAIMED
0308392	France	July 9, 2003	<input checked="" type="checkbox"/> YES <input type="checkbox"/> NO
03-02694		05 Mar 2003	<input type="checkbox"/> YES <input type="checkbox"/> NO

I hereby claim the benefit under Title 35, United States Code, § 119(e) of any United States provisional application(s) listed below.

PROVISIONAL APPLICATION NUMBER	FILING DATE

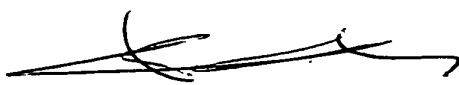
I hereby claim the benefit under Title 35, United States Code, § 120 of any United States application(s) listed below and, insofar as the subject matter of each of the claims of this application is not disclosed in the prior United States application in the manner provided by the first paragraph of Title 35, United States Code § 112, I acknowledge the duty to disclose information known to me which is material to patentability as defined in Title 37, Code of Federal Regulations, § 1.56 which became available between the filing date of the prior application and the national or PCT international filing date of this application:

NON-PROVISIONAL APPLICATION NO.	FILING DATE	STATUS		
		PATENTED	PENDING	ABANDONED

I hereby declare that all statements made herein of my own knowledge are true and that all statements made on information and belief are believed to be true; and further that these statements were made with the knowledge that willful false statements and the like so made are punishable by fine or imprisonment, or both, under Section 1001 of Title 18 of the United States Code and that such willful false statements may jeopardize the validity of the application or any patent issuing thereon.

SEND CORRESPONDENCE TO: WINSTON & STRAWN LLP
PTO Customer No. 28765

DIRECT TELEPHONE CALLS TO
Allan A. Fanucci at 212-294-3311

2 0 1	FULL NAME OF INVENTOR	LAST NAME POULENARD	FIRST NAME Michel	MIDDLE NAME	
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	POST OFFICE ADDRESS	STREET 152 rue de l'Hoirie	CITY Voreppe	STATE OR COUNTRY France	ZIP CODE 38340
		SIGNATURE OF INVENTOR 201 			DATE Spt. 9th